

Notice of References Cited	Application/Control No. 10/538,078	Applicant(s)/Patent Under Reexamination CHOI, SUNG-CHUL	
	Examiner Matthew L. Reames	Art Unit 2891	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code.	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP11354840	12-1999	JPO	Tanaka et al.	
	O	JP11354839	12-1999	JPO	Tanaka et al.	
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Tanaka et al. "GaN Quantum structures with Fractional Dimension From Quantum Well o Quantum Dot," phys. stat sol. (b) 216 481, 1999
	V	Tanaka et al, "Anti Surfactant in III-Nitride Epitaxy-Quantum Dot Formation and dislocation Termination," Japanese Journal of Applied Physics, Vol 39 8b, 2000
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.